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				Application Number	101705,579				
				Filing Date	November 10, 2003				
				First Named Inventor	Sridhar K. Kailasam				
				Art Unit	2813				
				Examiner Name	Colleen E. Rodgers				
Sheet	1	of	1	Attorney Docket Number	004.0048				

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(R)		D. JOSELL, D. WHEELER, C. WITT, and T.P. MOFFAT; "Seedless Superfill: Copper Electrodeposition in Trenches with Ruthenium Barriers"; Electrochemical and Solid-State Letters, Vol. 6; June 5, 2003; pp C143-C145. M.W. LANE, C.E. MURRAY, F.R. McFEELY, P.M. VEREECKEN AND R. ROSENBERG; "Liner	
O		Materials for Direct Electrodeposition of Cu"; Applied Physics Letters, Vol. 83, No. 12; September 22, 2003; pp 2330-2332.	
(P)		O. CHYAN, T.N. ARUNAGIRI AND T. PONNUSWAMY; "Electrodeposition of Copper Thin Film on Ruthenium, A Potential Diffusion Barrier for Cu Interconnects"; Journal of the Electrochemical Society, Vol. 150; October 8, 2002; pp C347-C350.	
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